

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant	:	Hada et al.
Appl. No.	:	10/563,705
Filed	:	January 5, 2006
For	:	RESIST COMPOSITION, LAMINATE, AND METHOD FOR FORMING RESIST PATTERN
Examiner	:	Chu, John S Y
Group Art Unit	:	1795

**AMENDMENT AND RESPONSE TO OFFICE ACTION****Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed March 3, 2008, please consider the following amendments and remarks:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.